

<b>Notice of References Cited</b>	Application/Control No. 10/562,121		Applicant(s)/Patent Under Reexamination BAUBET ET AL.	
	Examiner LAUREN ROBINSON		Art Unit 1794	Page 1 of 1

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*	C	US-2002/0139772 A1	10-2002	Fenner, David B.	216/60
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	K	US-			
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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Handbook of Sputer Deposition Technology"
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.